

**IN THE UNITED STATES PATENT  
AND TRADEMARK OFFICE**

Applicant: LOEPPERT ET AL.

Serial No.: 09/910,110

Filed: JULY 20, 2001

Title: RAISED MICROSTRUCTURE OF  
SILICON BASED DEVICE

Group Art Unit: 2643

Examiner: HUYEN D. LE

I hereby certify that this paper is being deposited with the United States Postal Service as first class mail, postage prepaid, in an envelope addressed to:  
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*RG*  
Randall G. Rueth  
Reg. No. 45,887

**AFTER FINAL RESPONSE TO THE ACTION  
DATED NOVEMBER 3, 2004**

10 not enter  
14/05  
Mail Stop AF  
Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Dear Sir:

This amendment is submitted in response to the Final action dated November 3, 2004. Applicants respectfully request reconsideration of the application in view of the following amendments and remarks.

Status of the Claims are reflected in the listing of claims which begins on page 2 of this paper.

Remarks begin on page 6 of this paper.

entry  
a/cce  
27/05  
JW